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Docket No.: 8733.517.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Seung-Kyu Choi et al.

Confirmation No.: 2898

Application No.: 10/028,304

Art Unit: 2826

Filed: December 28, 2001

Examiner: J. P. Mondt

For: THIN FILM TRANSISTOR SUBSTRATE AND
FABRICATING METHOD THEREOF

Customer No.: 30827

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 31, 2003 (Paper No. 12212003),
please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 3 of this paper.

Remarks begin on page 10 of this paper.